

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Evelyn L. Stump
Evelyn L. Stump, Paralegal

#6/A
1B/b
5-28-02

In the Application of Wilfred Lerch, et al.

Ser. No.: Not Yet Known (Based on PCT/EP00/03664 filed April 22, 2000 and German priority documents 199 20 322.9 filed May 3, 1999 and 19927 962.4 filed June 18, 1999)

For: METHOD OF GENERATING DEFECTS IN A GRID STRUCTURE OF A MICONDUCTOR MATERIAL

Filed on: November 3, 2001

Assistant Commissioner for Patents

Washington, DC 20231

PRELIMINARY AMENDMENT ACCOMPANYING PCT NATIONAL STAGE APPLICATION

Sir:

Prior to examination, please amend the above-identified application as follows.

IN THE SPECIFICATION:

On page 1, immediately after the title, please insert the following heading:

--Background of the Invention--.

On page 3, line 1, please insert the following heading:

--Summary of the Invention--.

On page 8, between lines 10 and 11, please insert the following heading:

ne --Brief Description of the Drawing--;

ne On page 9, between lines 17 and 18, please insert the following heading:

--Description of Preferred Embodiments--.

nc On page 10, line 9, after the word "torr", please insert --"(133 X 10⁻⁶ Pa)"--.